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If AFTER the later date of the first Office Action or 3 months from filing, use only with Rate 97(E)  Certificate or Fee				Customer No. 01333  Applicani: Venkata R. Gorantla, et al			
•	LIST OF ART CITED BY APPLICANT			Filing Date 12 September 2003			Be Assigned
U.S. PATENT DOCUMENTS							
Examiner Initial*	DOCUMENT NUMBER	DATE		NAME		SUBCLASS	FILING DATE  IF APPROPRIATE
EC	6540,935 B2	04-01-2003		Lee et al.			
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Examiner Initial*	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	TRANSLATION YES   NO
OTHER ART (Including Author, Title, Date, Pertinent Pages. Etc.)							
"Study of pattern density effects in chemical-mechanical planarization using fixed abrasive pads," by Venkata R. Gorantla et al., accepted for publication in Journal of Electrochemical Society (2003).							
	"Effects of mixed abrasives in chemical mechanical polishing of oxide films," by Zhenyu Lu, et al., to be published in Journal of Materials Research, October 2003, Vol. 18, No. 10.						
EXAMINER	Evie (		DATE CONSIDERED 6/22/05				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 6119; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							